

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Naoshi ADACHI

Art Unit:

Application No.: to be assigned

Examiner:

Filed: January 5, 2004

Attorney Dkt. No.: 12054-0023

For: HEAT TREATMENT JIG FOR SEMICONDUCTOR SUBSTRATE AND
METHOD OF HEAT TREATING SEMICONDUCTOR SUBSTRATE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 5, 2004

Sir:

Prior to examination on the merits of the above-identified application, please
amend the application as set forth below.

Amendments to the claims are submitted on page 2.

Remarks are submitted on page 5.